

Electronic Patent Application Fee Transmittal

Application Number:		10813829			
Filing Date:		30-Mar-2004			
Title of Invention:		Method of plasma etch endpoint detection using a V-I probe diagnostics			
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Filer:		Joseph A. Nguyen/Christine Teague			
Attorney Docket Number:		LMRX-P037/P1258			
Filed as Large Entity					
Utility Filing Fees					
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Basic Filing:					
Pages:					
Claims:					
Miscellaneous-Filing:					
Petition:					
Patent-Appeals-and-Interference:					
Post-Allowance-and-Post-Issuance:					
Extension-of-Time:					
Extension - 2 months with \$0 paid	1252	1	450	450	

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				1240